



# INSTYTUT TECHNOLOGII ELEKTRONOWEJ

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**INNOWACYJNA  
GOSPODARKA**  
NARODOWA STRATEGIA SPÓJNOŚCI

**UNIA EUROPEJSKA**  
EUROPEJSKI FUNDUSZ  
ROZWOJU REGIONALNEGO



DKZ/24/2009

Warsaw, 07.05.2009.

**Re: The open procedure for delivery of the laser lithography system.**

With regard to the following questions:

- 1. Some of the requested documents from the official authorities are only available in German. We would send the German original and attach a translation into English to the documents, I hope this will be ok.*
- 2. Your terms of payment are 60% after delivery and 40% after final acceptance - I am afraid we cannot agree to these terms because it is not possible to build and ship a system without having received any payment. Our standard terms are 30% downpayment with order, 60% with delivery and 10% after acceptance. This were also the payment conditions for the DWL200 which we delivered to the ITE in 2006 and which you agreed to. Would it be possible for you to agree to these payment terms again?*

we inform that:

**Ad. 1**

In the case the contractor will submit an original document in German language from the official authorities and attach a translation into English signed in front of the notary, the Awarding Entity will treat this document as valid.

**Ad. 2**

The Awarding Entity does not allow for any changes in point 16.3 of the Terms of Reference concerning terms of payments.

Zbigniew Poznański

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